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PATENT
Attorney Docket No.: SSI-04001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:) Group Art Unit: 1763
William Dale Jones) Examiner: Lund, Jeffrie Robert
Serial No.: 10/680,783) <u>TRANSMITTAL LETTER</u>
Filed: October 6, 2003) 162 N. Wolfe Road
For: HIGH PRESSURE PROCESSING) Sunnyvale, CA 94086
CHAMBER FOR A) (408) 530-9700
SEMICONDUCTOR WAFER) Customer No.: 28960

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

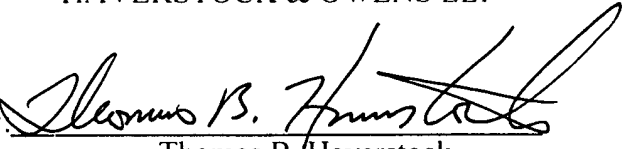
Sir:

Enclosed please find a Supplemental Information Disclosure Statement, a Certification pursuant to 37 C.F.R. § 1.97(e) for the Supplemental Information Disclosure Statement, and Form PTO-1449, including copies of the references contained thereon, for filing in the U.S. Patent and Trademark Office.

The Commissioner is hereby authorized to charge any additional fee or credit overpayment to our Deposit Account No. 08-1275. **An originally executed duplicate of this transmittal is enclosed for this purpose.**

Respectfully submitted,
HAVERSTOCK & OWENS LLP

Dated: 12-18-06

By: 
Thomas B. Haverstock
Reg. No.: 32,571

Attorneys for Applicant

CERTIFICATE OF MAILING (37 CFR § 1.8(c))
I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450

HAVERSTOCK & OWENS LLP

Date: 12/19/06 by Mary Beres



Attorney Docket No.: PATENT
SSI-04001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	Art Unit: 1763
William Dale Jones)	Examiner: Lund, Jeffrie Robert
Serial No.: 10/680,783)	<u>CERTIFICATION FOR</u>
Filed: October 6, 2003)	<u>SUPPLEMENTAL INFORMATION</u>
For: HIGH PRESSURE PROCESSING)	<u>DISCLOSURE STATEMENT UNDER 37</u>
CHAMBER FOR A)	<u>CFR § 1.97(e)</u>
SEMICONDUCTOR WAFER)	162 N. Wolfe Road
)	Sunnyvale, CA 94086
)	(408) 530-9700
)	Customer No.: 28960

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This certification is being made for the Supplemental Information Disclosure Statement accompanying this certification.

Certification

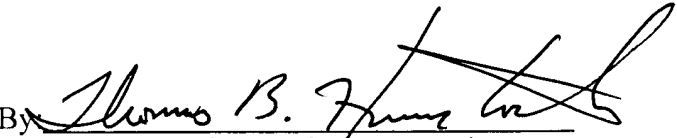
I hereby certify that the attached four (4) references contained in this supplemental information disclosure statement were cited within an International Search Report (ISR) mailed on October 20, 2006. **Accordingly, the references contained in the supplemental information disclosure statement were cited in a communication from a foreign patent office in a counterpart application not more than three months prior to the filing of the statement. 37 C.F.R. 1.97(e)(1).**

Identification of Person Making Certification

The person making this certification is the attorney who signs below on the basis of the information in the attorney's file.

Respectfully submitted,
HAVERSTOCK & OWENS LLP

Dated: 12-18-06

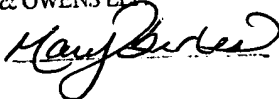
By 
Thomas B. Haverstock
Reg. No.: 32,571

Attorneys for Applicant

CERTIFICATE OF MAILING (37 CFR § 1.8(a))

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450

HAVERSTOCK & OWENS LLP

Date: 12/19/06 By: 



Attorney Docket No.: PATENT
SSI-04001

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

William Dale Jones

Serial No.: 10/680,783

Filed: October 6, 2003

For: **HIGH PRESSURE PROCESSING
CHAMBER FOR A
SEMICONDUCTOR WAFER**

) Group Art Unit: 1763

) Examiner: Lund, Jeffrie Robert

) **SUPPLEMENTAL INFORMATION**
) **DISCLOSURE STATEMENT**

) 162 N. Wolfe Road
) Sunnyvale, CA 94086
) (408) 530-9700

) Customer No.: 28960

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The citations listed below, copies attached, may be material to the examination of the above-identified application, and are therefore submitted in compliance with the duty of disclosure defined in 37 C.F.R. §§ 1.56 and 1.97. The Examiner is requested to make these citations of official record in this application.

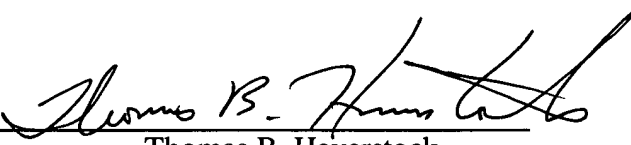
Applicant has become aware of the following printed publications which may be material to the examination of this application:

- U.S. Patent No. 6,558,475 B1;
- U.S. Publication No. 2002/0014257 A1;
- U.S. Publication No. 2004/0103922 A1; and
- U.S. Publication No. 2004/0211440 A1.

This Supplemental Information Disclosure Statement under 37 C.F.R. §§ 1.56 and 1.97 is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that anyone or more of these citations constitutes prior art.

Respectfully submitted,
HAVERSTOCK & OWENS LLP

Dated: 12-18-06

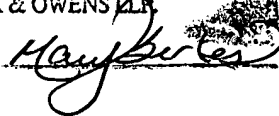
By: 
Thomas B. Haverstock
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Attorneys for Applicant

CERTIFICATE OF MAILING (37 CFR § 1.8(a))

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HAVERSTOCK & OWENS LLP

Date: 12/19/06 By: 

FORM PTO-1449
(Modified)U.S. Department of Commerce
Patent and Trademark Office

Attorney Docket No.: SSI-04001

Serial No.: 10/680,783

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Applicant: William Dale Jones

(37 CFR § 1.98(b))

Filing Date: October 6, 2003

Group Art Unit: 1763

U.S. PATENT DOCUMENTS

Examiner Initials		Serial / Patent Number	Issue Date	Applicant / Patentee	Class	Subclass	Filing Date
	AA	6,558,475 B1	5/6/03	Jur et al.	134	21	4/10/00
	AB	US 2002/0014257 A1	2/7/02	Chandra et al.	134	19	5/18/01
	AC	US 2004/103922 A1	6/3/04	Inoue et al.	134	26	11/21/02
	AD	US 2004/0211440	10/28/04	Wang et al.	134	2	4/24/03
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						

FOREIGN PATENTS OR PUBLISHED FOREIGN PATENT APPLICATIONS

		Document Number	Publication Date	Country / Patent Office	Class	Subclass	Translation	
							Yes	No
	AK							
	AL							
	AM							
	AN							
	AO							
	AP							
	AQ							
	AR							
	AS							
	AT							

OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication)

	AU	
	AV	
	AW	
	AX	
	AY	
	AZ	
	BA	
	BB	
	BC	
	BD	
	BE	

Examiner:

Date Considered:

EXAMINER: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.